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Patent

Customer No. 31561 Docket No. 10573-US-PA Application No.: 10/604,793

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Applicant Application No. : Rui-Hui Wen : 10/604,793

Filed

For

: ION SAMPLING SYSTEM FOR WAFER AND SAMPLING

METHOD THEREOF

Examiner

:TBA

: 1746 Art Unit

INFORMATION DISCLOSURE STATEMENT

002-1-571-273-8300 (Via fax: 2+11 pages)

United States Patent and Trademark Office Customer Service Window, Mail Stop Amendment Randolph Building 401 Dulany Street Alexandria, VA 22314

Enclosed is a PTO Form 1449 listing 1 reference, copy of which is attached. Applicant submits the reference in compliance with their duty of disclosure pursuant to 37 CFR § 1.56 and 1.97. The Examiner is requested to make the citation of official record.

This IDS is being submitted before the first Office Action. Thus, it is believed no fee is due.

The submission of the reference should not be interpreted as admitting them as prior art.

Respectfully Submitted, JIANQ CHYUN Intellectual Property Office

Date: 15t. 31. 2505

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PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICATION			ATTY. DOCKET NO.:10573-US-PA		APPLICATION NO.: 10/604,793	
			APPLICANT: Rui-Hui Wen			
			FILING DATE: August 18, 2003		GROUP 1746	
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INITIAL	2000-005710	January 11, 2000	Japan			
				MATE DATE D	ERTINENT PAGES	ETC.)
EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)					
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